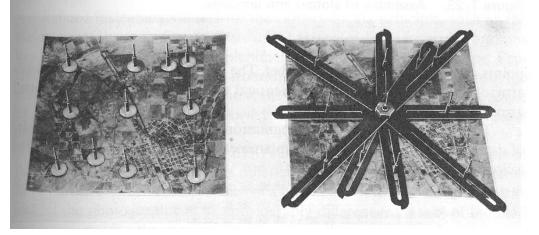


Figure 7-21. Slotted metal arms.

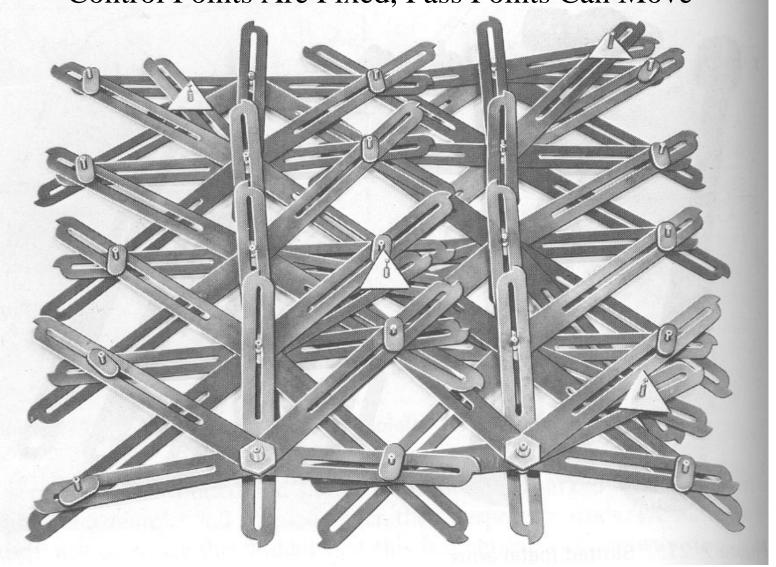


Slotted Template equipment for doing radial line triangulation (2D)

Assumptions: vertical, frame imagery

A 10-Photo Block "Computed" by Radial Line Templates

Control Points Are Fixed, Pass Points Can Move



Another Approach to Radial Line Method – Slotted Templates Made from Cardboard

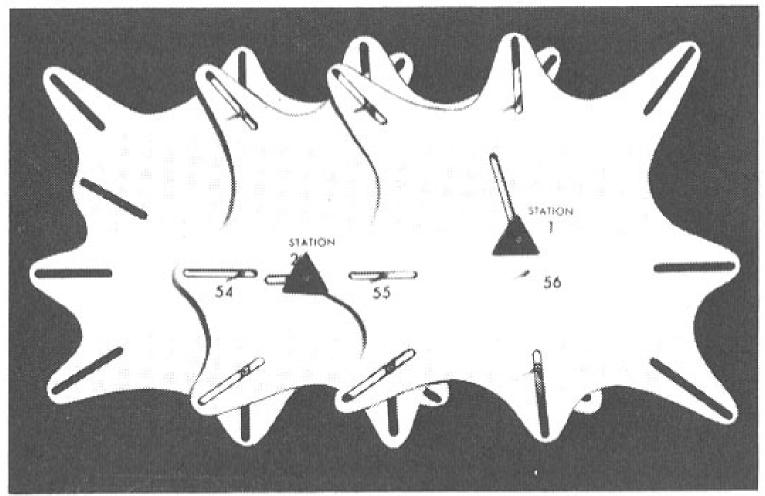


FIGURE 9-2. Slotted templets.

Cutting the Slotted Template

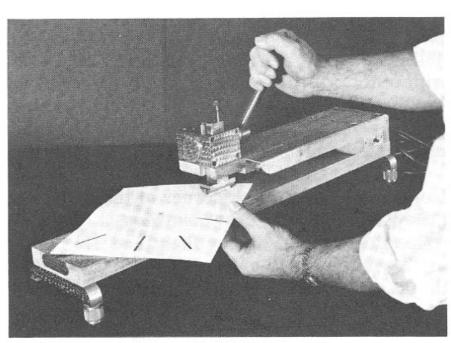
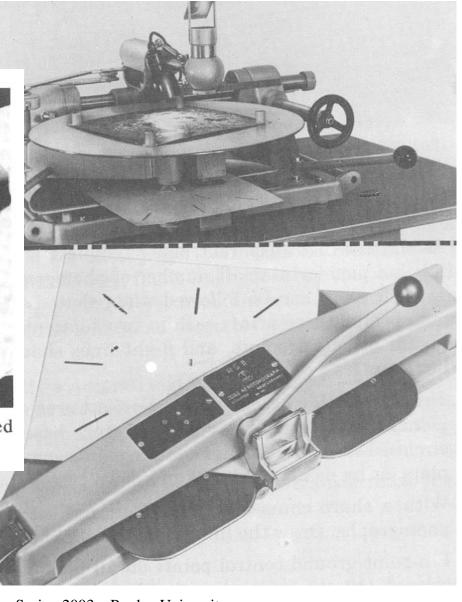


FIGURE 9-3. Slot cutter for preparation of slotted templet.



"Adjusting" a Large Photogrammetric Block by Radial Line Method



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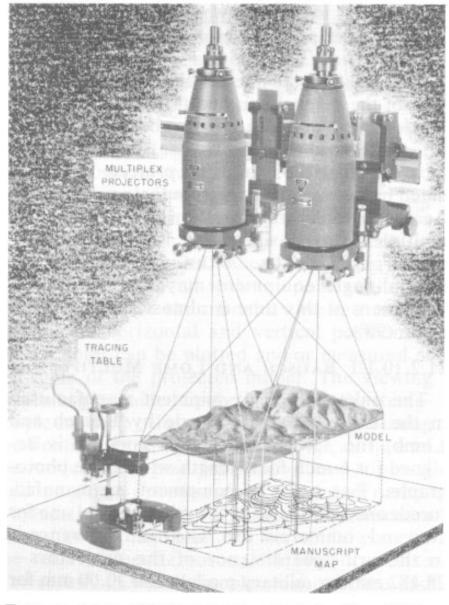


FIGURE 11-1. Diagrammatic sketch of multiplex model.

Optical projection stereo plotter "multiplex" used for both map compilation and aerial triangulation Multiple optical projection plotters allow multiple models in a continuous strip to be formed and linked – creating a continuous 3D model of the strip – now you don't need control in every model!

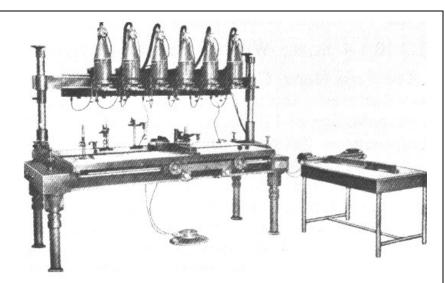


FIGURE 11-5. Nistri Photomultiplex Model-D III.

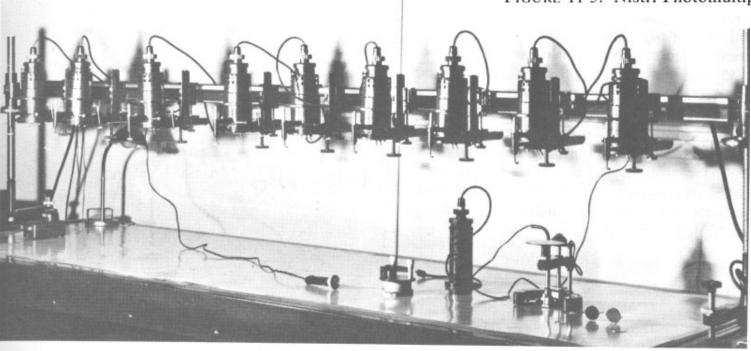
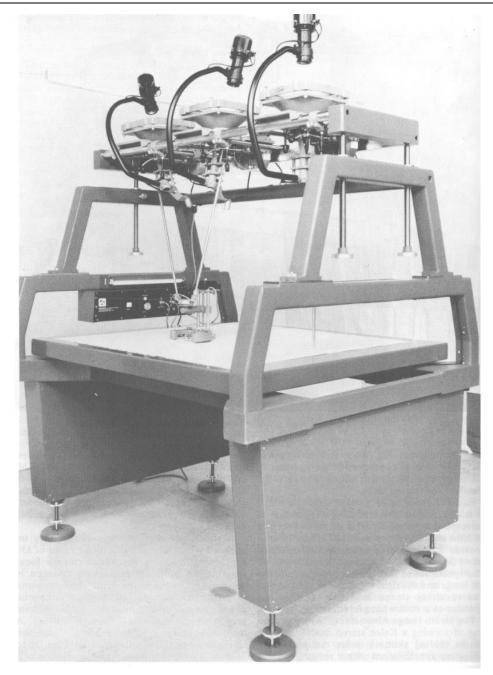


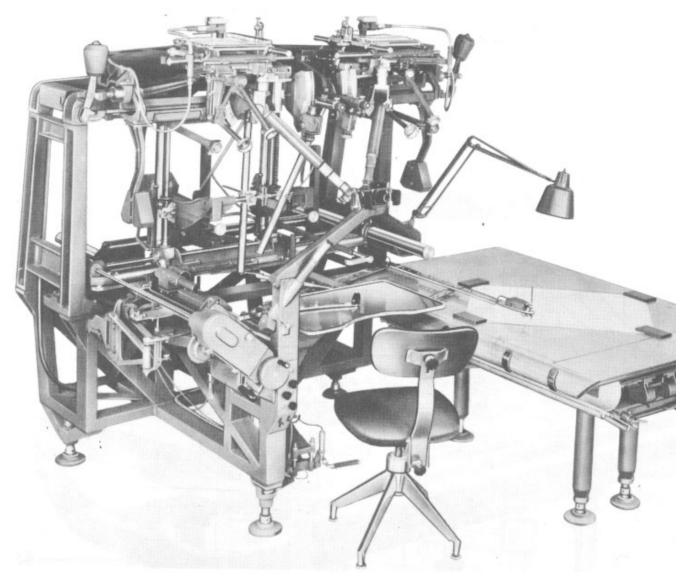
FIGURE 11-7. Zeiss (Jena) super-wide-angle multiplex.



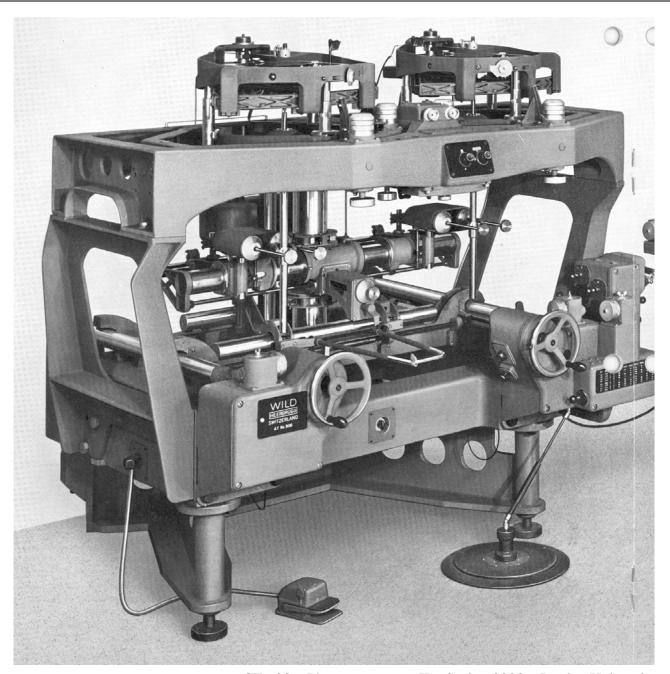
3-projector version of the venerable Kelsh plotter – used full size diapositives, mutltiplex instruments used reduced scale diapositives

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Santoni instrument using mechanical projection – used for map compilation as well as independent model triangulation



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Wild A7 Triangulation Instrument

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Wild PUG (Punkt Ubertragungsgeraet)

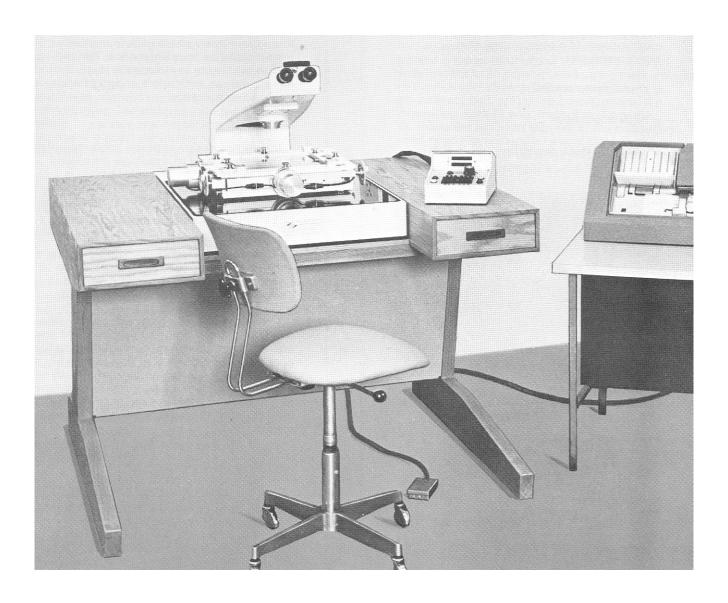


Mann Monocomparator



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Space Optics Monocomparator



Zeiss Monocomparator

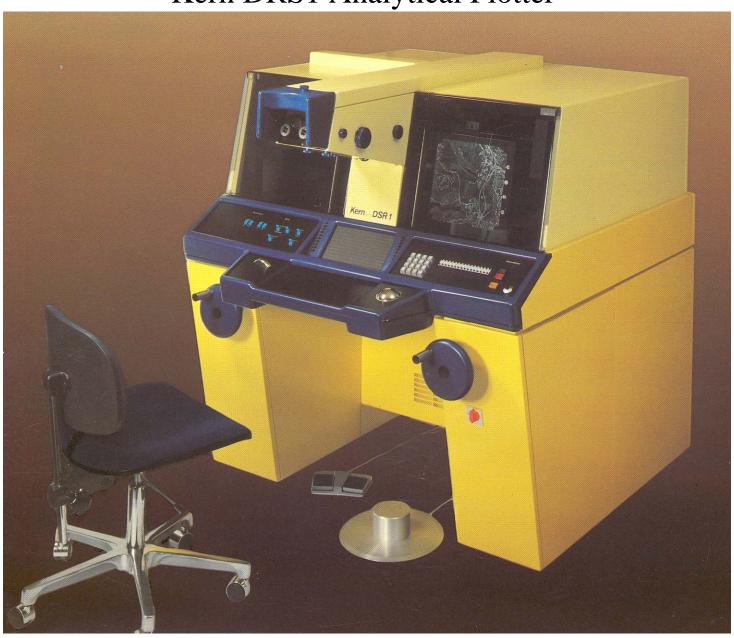


Kern CPM-1 Comparator / Point Marker



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Kern DRS1 Analytical Plotter



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Zeiss P3 Analytical Plotter



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